## AMENDMENTS TO THE CLAIMS

This listing of claims will replace all prior versions, and listings, of claims in the present application:

## **Listing of Claims:**

1. (Currently Amended) A method for treating an implant surface intended for implantation into bone tissue, e h a r a c t e r i s -e d in said method comprising:

providing a microroughness onto said implant surface by treating the metallic implant surface with an aqueous solution of hydrofluoric acid;

wherein said microroughness eomprising comprises pores and peaks having a pore diameter of  $\leq 1 \mu m$ , a pore depth of  $\leq 500 nm$ , and a peak width, at half the pore depth, of from 15 to 150% of the pore diameter, and

the implant surface is a metallic implant surface.

- 2. (Currently Amended) [[A]] The method according to claim 1, wherein the pore diameter is within the range of 50 nm to 1 µm and the pore depth is within the range of 50 to 500 nm.
- 3. (Currently Amended) [[A]] The method according to claim 1 or 2, wherein a rootmean-square roughness ( $R_q$  and/or  $S_q$ ) of  $\leq 250$  nm is provided.

## 4-5. (Cancelled)

6. (Currently Amended) [[A]] The method according to claim [[5,]] 1 or 2, wherein the

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concentration of the hydrofluoric acid is less than 0.5 M.

7. (Currently Amended) [[A]] The method according to claim [[6,]] 1 or 2, wherein the

metallic implant surface is treated for an etching period of up to 180 sec at room temperature.

8. (Currently Amended) [[A]] The method according to claim 7, wherein the

concentration of the hydrofluoric acid is 0.1 M and the etching period is up to 60 sec at room

temperature.

9. (Currently Amended) [[A]] The method according to claim 1 or 2, further comprising

providing a macroroughness on the implant surface prior to providing the microroughness.

10. (Currently Amended) [[A]] The method according to claim 9, wherein the

macroroughness is provided by blasting the implant surface.

11. (Currently Amended) [[A]] The method according to claim 1 or 2, wherein said

metallic implant surface is made of commercially pure titanium or an alloy of titanium.

12. (Cancelled)

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13. (Currently Amended) An implant for implantation into bone tissue having an

implant surface e h a r a c t e r i s e d characterized in that at least a part of the implant surface

comprises a microroughness which comprise pores and peaks having a pore diameter of  $\leq 1 \mu m$ ,

a pore depth of  $\leq 500$  nm, and a peak width, at half the pore depth, of from 15 to 150% of the

pore diameter.

14. (Currently Amended) [[An]] The implant according to claim 13, wherein the pore

diameter is within the range of 50 nm to 1 µm and the pore depth is within the range of 50 to 500

nm.

15. (Currently Amended) [[An]] The implant according to claim 13 or 14, wherein the

microroughness has a root-mean-square roughness ( $R_a$  and/or  $S_a$ ) of  $\leq 250$  nm.

16. (Currently Amended) [[An]] The implant according to claim 13 or 14, wherein the

implant surface further comprises a macro-roughness.

17. (Currently Amended) [[An]] The implant according to claim 13 or 14, wherein said

implant is a metallic implant.

18. (Currently Amended) [[An]] The implant according to claim 17, wherein said

metallic implant is made of commercially pure titanium or an alloy of titanium.

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19. (Currently Amended) [[An]] The implant according to claim 13 or 14, wherein the implant is a dental implant.

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20. (Currently Amended) [[An]] The implant according to claim 13 or 14, wherein the implant is an orthopaedic implant.